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|---|----|---|--|----------------|---------|--|-------------------------------------|----|----------------------------|
| APPLICANTS Andrew M. Hoff, Tampa, FL; CONTINUING DATA This appln claims benefit of 60/319,607 10/11/2002 FOREIGN APPLICATIONS FREQUIRED, FOREIGN FILING LICENSE GRANTED SMALL ENTITY 101/15/2004 | | | | | | | | | |
| DELICO (18) (a d) conditions | | | | | | EETS TOT | | MS | INDEPENDENT CLAIMS 3 |
| 21901 TITLE Method of Forming Thin Silicon Oxide Films on Silicon Carbide Substrates | | | | | | | | | |
| | | | | | | ☐ All Fees ☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of | | | |
| FILING FEE FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following: | | | | | | time) 1.18 Fees (issue) Other Credit | | | |